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MICRON.240A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ammar Derraa et al.
Appl. No. : 09/944,903
Filed : August 30, 2001
For : HIGH ASPECT RATIO
CONTACT STRUCTURE
WITH REDUCED SILICON
CONSUMPTION

) Group Art Unit 2826
)

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) and Trademark Office, P.O. Box 2327, Arlington,
) VA 22202, on

August 19, 2002

(Date)

Linda H. Liu, Reg. No. 51,240

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Examiner : Victor A. Mandala

RESPONSE TO RESTRICTION REQUIREMENT

United States Patent and Trademark Office
P.O. Box 2327
Arlington, VA 22202

Dear Sir:

In response to the Office Action mailed August 2, 2002, please amend the above captioned application as follows:

IN THE CLAIMS

Please cancel Claims 19-26 without prejudice.

REMARKS

In the Office Action, the Examiner imposed a restriction requirement on the above-captioned application under 35 U.S.C. §121 and requested the Applicant to elect the invention to be examined. Pursuant to the Examiner's request, Applicant hereby elects to restrict the above-captioned application to Claims 1-18 without traverse and cancels Claims 19-26 without prejudice. Applicant respectfully submits that the application is now in compliance with 35 U.S.C. §121. Hence, reconsideration of the above-captioned application in light of the amendments and remarks contained herein is respectfully requested. Please charge any additional

Appl. No. : 09/944,903
Filed : August 30, 2001

fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 8/19/2002

By: 

Linda H. Liu

Registration No. 51,240

Attorney of Record

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Date: August 19, 2002

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In re application of : Ammar Derraa et al.

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ATTN: BOX NO FEE AMENDMENT

Sir:

Transmitted herewith is a Response to Restriction Requirement in the above-identified application.

The fee has been calculated as shown below:

CLAIMS AS FILED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	18	26	= 0 ×	\$18	= \$0
Independent Claims	2	3	= 0 ×	\$84	= \$0
If application has been amended to contain multiple dependent claim(s), then add				\$280	= \$0
Time Extension Fee					\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

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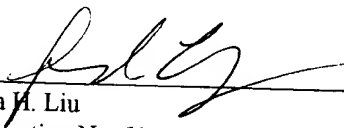
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Date: August 19, 2002

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